

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 7,697,260 B2
APPLICATION NO. : 10/816152
DATED : April 13, 2010
INVENTOR(S) : Brown et al.

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Column 4, line 16 the text "AIN" should read --AlN-- to indicate Aluminum Nitride.

Column 9, line 48 cancel the text beginning with "8. A chuck according to" and ending with "stainless steel." in column 9, line 50 and insert the following claim:

--8. A chuck assembly according to claim 7 wherein the first material comprises copper and the second material comprises stainless steel.--

Column 9, line 59 cancel the text beginning with "12. A substrate processing chamber" and ending with "exhaust the gas." in column 9, line 62 and insert the following claim:

--12. A substrate processing chamber comprising the electrostatic chuck assembly of claim 4 and further comprising a gas supply to provide a process gas in the chamber, a gas energizer to energize the gas, and an exhaust to exhaust the gas.--

Signed and Sealed this

Twenty-seventh Day of July, 2010

A handwritten signature in black ink that reads "David J. Kappos". The signature is written in a cursive, flowing style.

David J. Kappos
Director of the United States Patent and Trademark Office